



Manufacture using Advanced Powder Processes EPSRC Future Manufacturing Hub

# Prevention is better than Cure In-situ Monitoring and Machine Learning

**Iain Todd** 

Director, MAPP EPSRC Future Manufacturing Hub
RAEng / GKN Aerospace Research Chair
Department of Materials Science and Engineering
The University of Sheffield



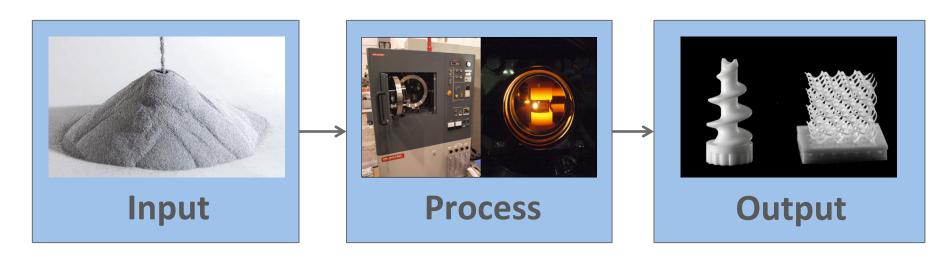








#### **Current situation**



**Variable** 

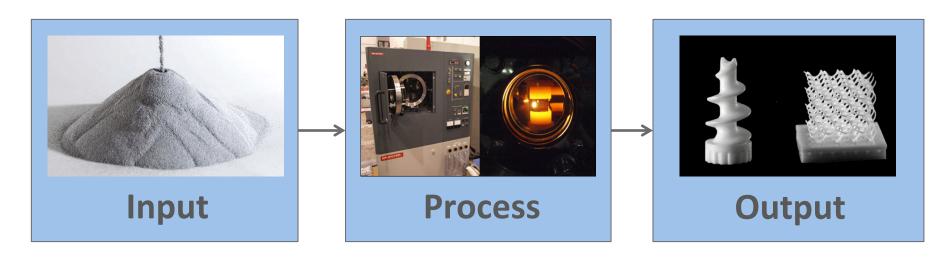
**Fixed** 

**Variable** 

Limited or no monitoring



## **MAPP** Approach



Designed for process

Monitored

Dynamic control via machine learning

Designed

Quality built in





Manufacture using Advanced Powder Processes EPSRC Future Manufacturing Hub

#### **Defects**

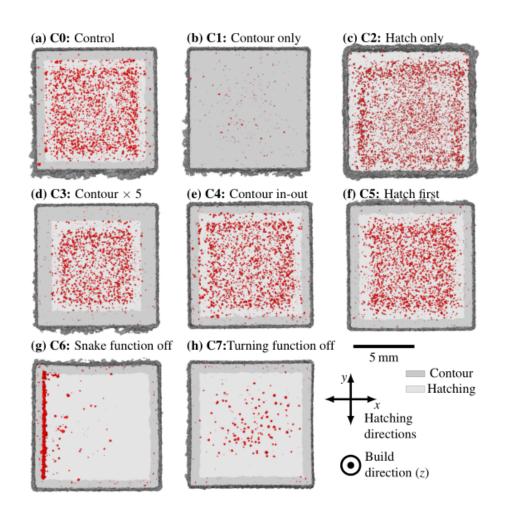








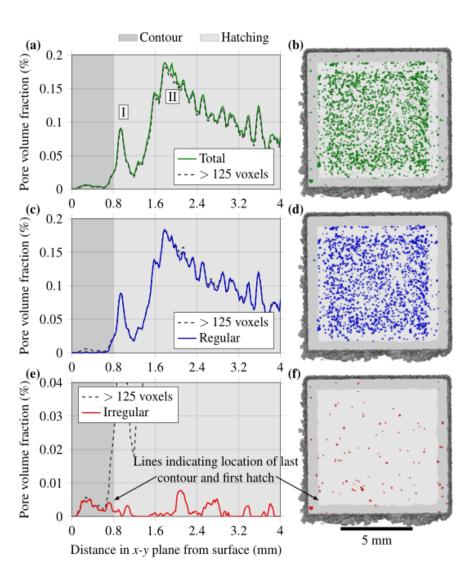
#### "Defects" are clearly a function of process parameters

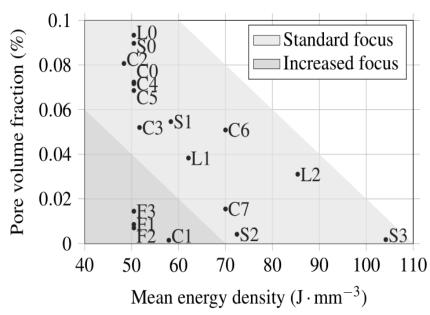


In a single build, the number of defects (red) can be altered by changing the melt strategy.

Red = high circularity defects (gas pores)

S. Tammas-Williams, H. Zhao, F. Léonard, F. Derguti, I. Todd, P.B. Prangnell, XCT Analysis of the Influence of Melt Strategies on Defect Population in Ti-6Al-4V Components Manufactured by Selective Electron Beam Melting, Mater. Charact. 102 (2015) 47–61.





$$E.D = \frac{q}{v.l.h}$$

Where:

q = Beam power

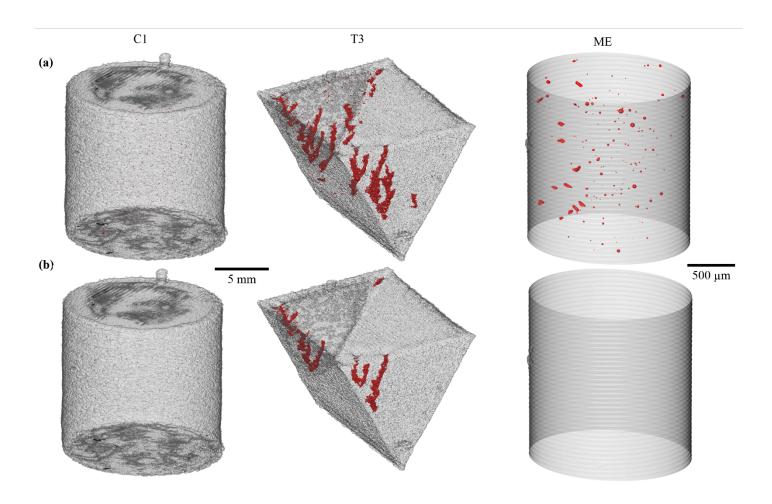
v = Beam traverse rate

/ = Layer thickness

*h* = Hatch offset

S. Tammas-Williams, H. Zhao, F. Léonard, F. Derguti, I. Todd, P.B. Prangnell, XCT Analysis of the Influence of Melt Strategies on Defect Population in Ti-6Al-4V Components Manufactured by Selective Electron Beam Melting, Mater. Charact. 102 (2015) 47–61.

# HIP

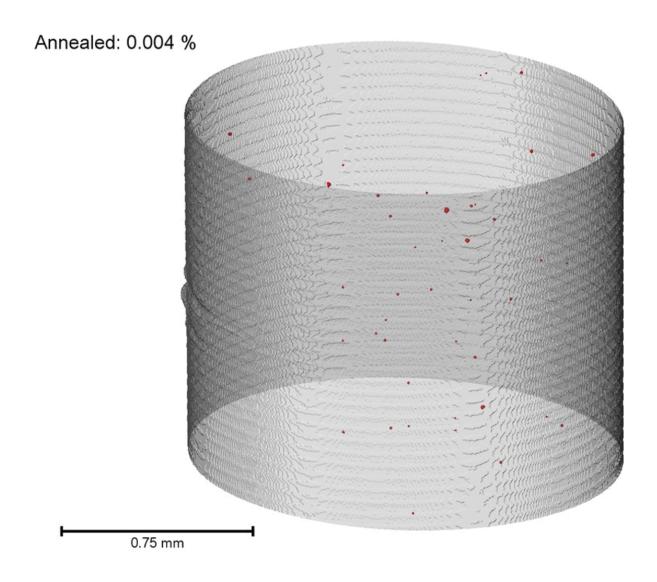


Whilst HIPing is undoubtedly good – it is not a "cure all"

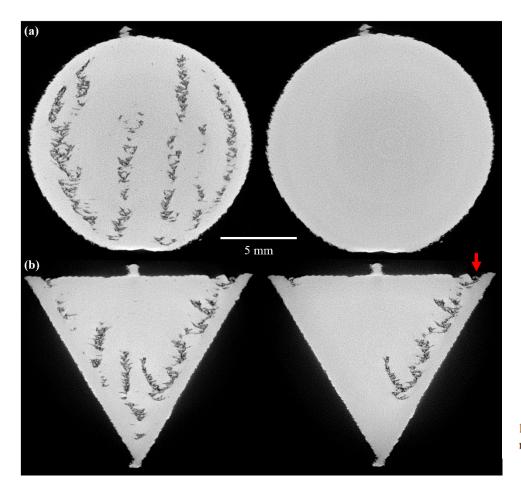
S. Tammas-Williams et al. Metallurgical and Materials Transactions A May 2016, Volume 47, Issue 5, pp 1939–1946

#### **Defects**

#### **After HIPing and heat treatments**



#### As-built HIP



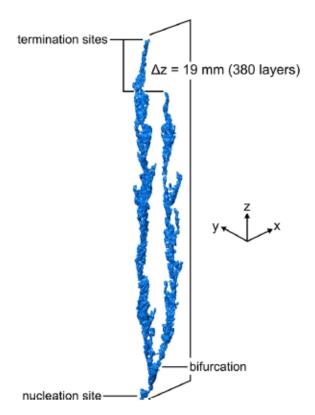


Figure 3 Chimney pore that split into two branches soon after it nucleated.

From Cordero et al.J Mater. Sci 52, (2017), 3429-3435

# Prevention is better than Cure (1): In-situ Detection



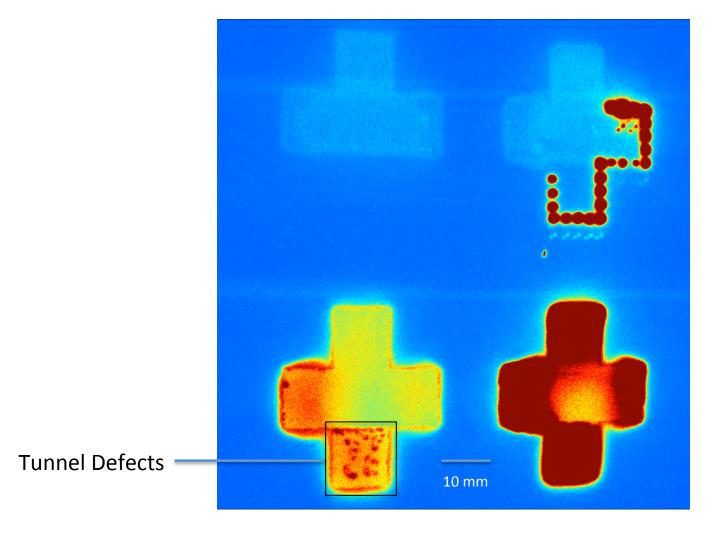
# Thermal camera 12 Specifications





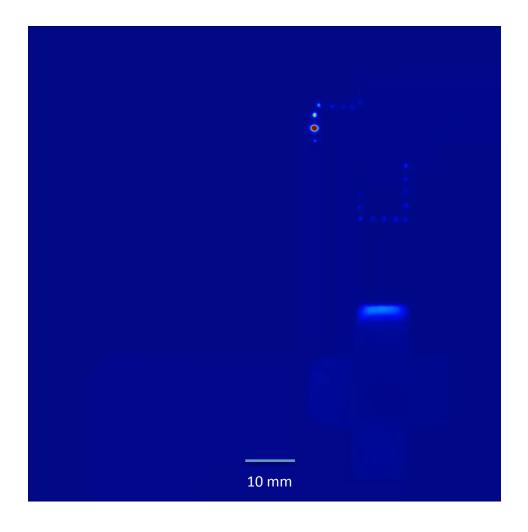
#### Thermal camera 13

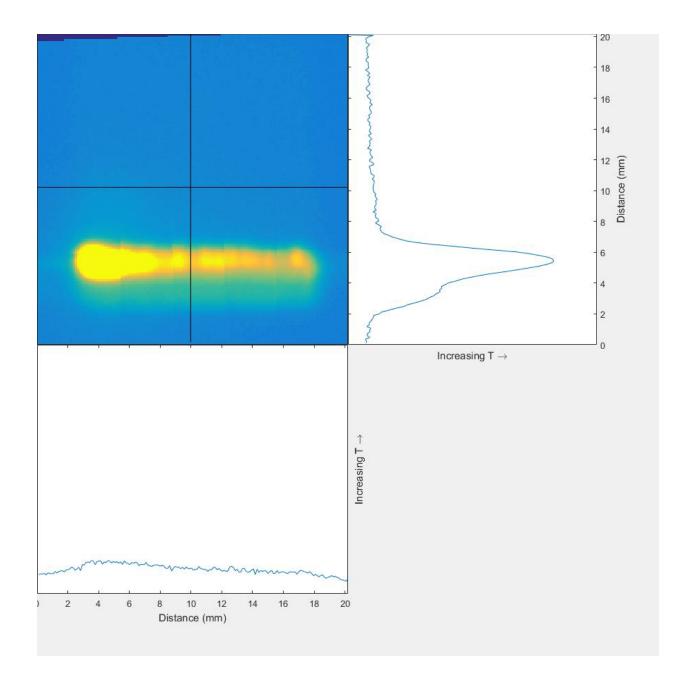
#### **Example Footage**



#### Thermal camera 14

#### **Example Footage**

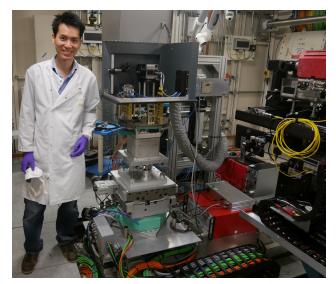




In situ AM Synchrotron Setup



**Diamond Light Source** 



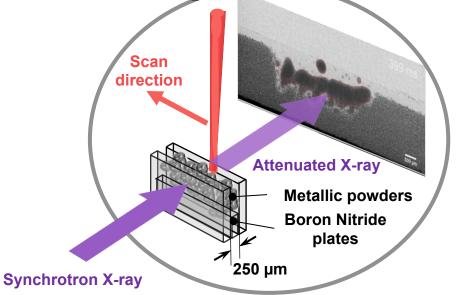
In situ AM on Beamline I12

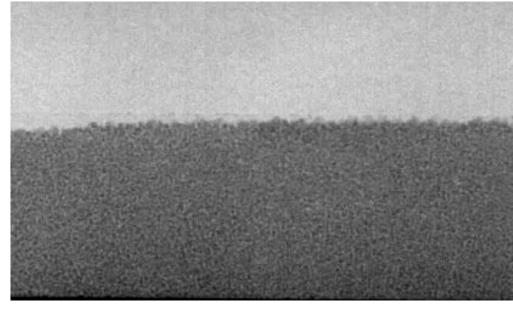
Leung, Lee, Towrie et al, Funding EPSRC (RCaH&MAPP), FP7











SS316, 200W, 7.5mm/s, 5000fps

# Prevention is better than Cure (2): Control (Machine Learning)





Manufacture using Advanced Powder Processes EPSRC Future Manufacturing Hub

# Model-Based Feature Selection Based on Radial Basis Functions and Information Theory

**George Panoutsos** 

g.panoutsos@sheffield.ac.uk





EU H2020: Factories of The Future Agreement no. 636902







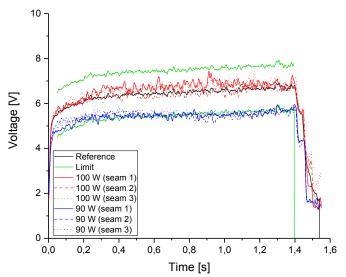


## **Human-Centric Systems**

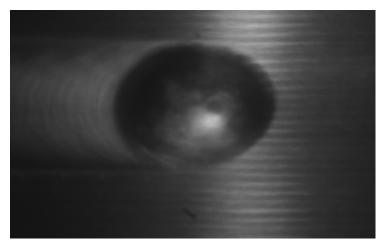
- Human-Centric Systems: Computational Systems designed for user-centred information processing
  - Frameworks that mimic human cognition, i.e. incremental learning, learning from examples etc.
  - Systems that are easy to interpret and interact with –
     by non-experts i.e. linguistic interpretability

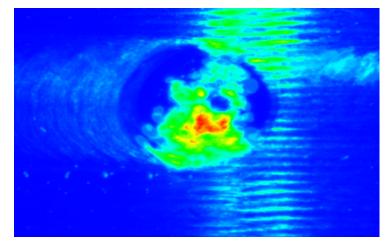
### **Process monitoring**

- High-speed imaging and bespoke illumination system for melt pool monitoring
- Spectral monitoring



Courtes:y LZH, CAVITAR



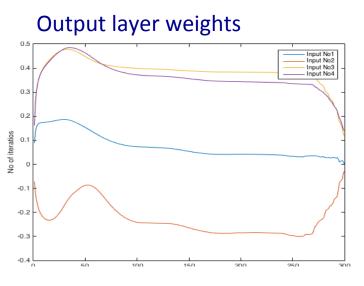


Courtesy: 4D

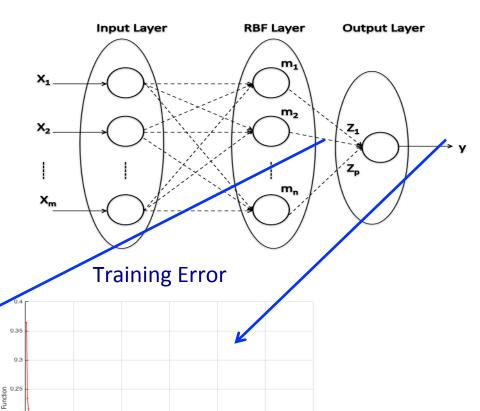
### Methodology

- Construct a modelling framework based on a data-driven approach (model output: defects)
- Develop a fast, but transparent 'learning' methodology for the model
- Observe (algorithmically) how the model learns from data
- Use information theory to link the learning performance of the model to the input signals (process monitoring)

The model's learning evolution (training error) is linked directly to the model's inputs (monitoring signals)



$$Zi = w_1 x_1 + w_2 x_2 + \dots + w_j x_j + \dots + w_m x_m$$



(11)

0.15

where  $w_j$  is the weight for the correspond input  $x_j$ .

Each model input 'xj' corresponds to a metric from the process monitoring signals

Hypothesis: For two data sequences (model weights – evolution of model learning) we can use information-theoretic measures to identify relevance/importance:

#### Cross-sample entropy is used [1]:

For two normalized sequences x(i) and y(i),  $1 \le i \le N$ , the vector sequences  $X_i^m$  and  $Y_j^m$  were formed as follows:

$$X_{i}^{m} = \left\{x(i), x(i+1), ..., x(i+m-1)\right\}$$
 (5)

$$Y_j^m = \{y(j), y(j+1), ..., y(j+m-1)\}$$
 (6)

where  $1 \le i, j \le N - m$ , N is the number of data points of each time series and m (embedding dimension) and r (tolerance limits of similarity) are fix parameters.

The distance between  $X_i^m$  and  $Y_j^m$  is defined as:

$$d_{i,j}^{m} = d[X_{i}^{m}, Y_{j}^{m}] = \max |x(i+k) - y(j+k)|$$
 (7)

where  $1 \le k \le m-1$ .

For each 
$$i \le N - m$$
, denote:

$$B_{i}^{m}(r)(x \parallel y) = \frac{number\_of\_j\_that\_meets\_d_{i,j}^{m} \le r}{N-m}$$
 (8)

and

$$A_i^m(r)(x \parallel y) = \frac{number\_of\_j\_that\_meets\_d_{i,j}^{m+1} \le r}{N-m}$$
(9)

CSE is defined as:

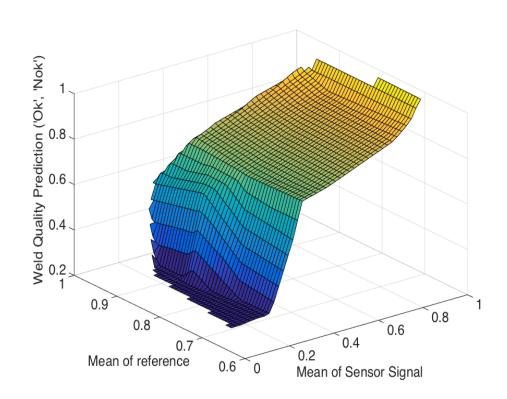
Cross - SampEn(m,r,N) = -ln 
$$\left( \frac{\sum_{i=1}^{N-m} A_i^m(r)(x \parallel y)}{\sum_{i=1}^{N-m} B_i^m(r)(x \parallel y)} \right)$$
 (10)

[1] G. Tzagarakis and G. Panoutsos, Model-Based Feature Selection Based on Radial Basis Functions and Information Measures, Proceedings of the 2016 IEEE World Congress on Computational Intelligence, Canada (2016)

#### Simulation results

- Simulation results on a sample of 81 welds
- 80 features from the monitoring signals were used to create the overall dataset
- Most important metric linked to defects:
  - Mean of reference width measurement (meltpool)

# Example model-based defect prediction surface



#### What Next?

- Development of Deeper Process "rules"
- Performance by Design building from / on
  - models of differing levels of complexity generation of Axioms
  - data acquisition in and ex-situ and in-operando (see P.Lee talk later...)
  - direct observation visual, hyperspectral, resistance etc.
- Capacity to Develop "cyber-physical" manufacturing environments – Human Centric but Machine Learning enabled
- This is a clear intersection of AM and Industry 4.0 but should enable the promise of AM (and other processes) to be fulfilled.



# **Our Partners**



Engineering and Physical Sciences Research Council





























freemantechnology









Advanced Manufacturing Research Centre









